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Deep level transient spectroscopic study of neutron-irradiated 
n-type 6H–SiC

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Deep level transient spectroscopy has been employed to study the deep level defects introduced in 
n-type 6H–SiC after neutron irradiation. Deep levels situated at $E_C - 0.23$, $E_C - 0.36/0.44$, $E_C - 0.50$, and $E_C - 0.62/0.68$ eV have been detected in the temperature range of 100–450 K, which 
have been identified with the previously reported deep levels $ED1$, $E1/E2$, $Ei$, and $Z1/Z2$, 
respectively. Thermal annealing studies of these deep levels reveal that $ED1$ and $Ei$ anneal at 
a temperature below 350 °C, the $Z1/Z2$ levels anneal out at 900 °C, while the intensity of the $E1/E2$ 
peaks is increased with annealing temperature, reaching a maximum at about 500–750 °C, and 
finally annealing out at 1400 °C. The possible nature of the deep levels $ED1$, $E1/E2$, $Ei$, and $Z1/Z2$ 
are discussed in the context of their annealing behavior. Upon further annealing at 1600 °C, four 
deep levels labeled $NE1$ at $E_C - 0.44$ eV, $NE2 E_C - 0.53$ eV, $NE3 E_C - 0.64$ eV, and $NE4 E_C - 0.68$ eV are produced. Evidence is given that these levels are different in their origin to $E1/E2$ and 

I. INTRODUCTION

Silicon carbide (SiC) is a wide band-gap semiconductor 
material having unique physical and electronic properties for 
high-temperature, high-power, and high-frequency electronic 
device applications. In modern SiC device technology, electron 
irradiation and ion implantation are usually employed for the purposes of carrier lifetime control and creating 
doped layers. It is always found that irradiation-induced de- 
defects remain in the operating area of the device even after the 
annealing procedure. In past years, deep level defects in- 
duced by particle irradiation or ion implantation in SiC have 
been extensively studied by capacitance transient techniques 
such as deep level transient spectroscopy (DLTS). Deep 
levels at $E_C - 0.6–0.7$ eV (termed $Z1/Z2$) have been re- 
ported to be persistent even after thermal annealing at 1700 °C and are generated either by irradiation with high- 
energy electrons or by implantation of ions. However, re- 
cent DLTS studies of the thermal annealing behavior of the 
$Z1/Z2$ levels have shown that these levels almost disappear 
with postirradiation annealing temperatures below 1000 °C. Another important grouping of deep levels are those 
found at $E_C - 0.36$ and $E_C - 0.44$ eV (usually termed 
$E1/E2$). These peaks are normally seen in the DLTS spectra of electron-irradiated 6H–SiC. However, in the studies of He implanted and deuterium implanted n-type 6H–SiC, 
$E1/E2$ are not clearly detectable in as-irradiated samples, but they become so after thermal annealings of 430 °C and

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defect levels has been discussed according to their observed thermal annealing behavior.

II. EXPERIMENT

The starting n-type 6H–SiC samples used in this experiment were purchased from CREE Research Inc. in the form of a 5-μm-thick nitrogen doped (0001) oriented epitaxial layer grown on n⁺-type 6H–SiC substrate. The nitrogen donor concentrations were 1 \times 10^{10} and 8 \times 10^{11} cm^{-3} in the epitaxial layer and the substrate, respectively. The samples were rinsed in boiling acetone, ethanol, and de-ionized water, and were then chemically treated in 10% hydrofluoric acid solution to remove the oxidation layer. Large area ohmic contacts were made by depositing Al on the backside of the samples followed by a 5 min annealing process at 900 °C in pure nitrogen gas.

The samples were irradiated with neutrons at room temperature to doses of 5.1 \times 10^{13}, 2.5 \times 10^{14}, and 1 \times 10^{15} n/cm², respectively. The flux ratio of fast neutrons to thermal neutrons was around 30%. Isochronal thermal annealing of the irradiated samples was carried out in an atmosphere of nitrogen gas at temperatures between 100 and 1100 °C for 30 min. Higher temperature annealing at 1200, 1400, and 1600 °C were performed for 30 min in pure argon gas. Schottky contacts for DLTS measurement were prepared by depositing gold dots of 0.6 mm diameter by thermal evaporation on the surface of epitaxial layer.

The DLTS system used in the present work has been described elsewhere. These measurements were carried out by applying a reverse bias of V_r = -6 V, with a forward filling pulse of V_p = 6 V. DLTS spectra were taken in the range of 100–450 K. The trap energy levels and capture cross sections were determined from the slope and the intercept of the Arrhenius plots using the equation e_n/T^2 = \gamma_n \sigma n \exp(-E_C-E_I/kT) where e_n is the rate of emission from the trap to the conduction band, \gamma_n is a constant parameter, E_C is the trap energy level, and \sigma_n is the capture cross section, and (E_C-E_I) is the deep level activation energy. The trap concentration was evaluated from the peak heights of the DLTS signal using the procedure described in Ref. 20. In the calculations, the defect capture cross sections were assumed to be temperature independent.

### TABLE I. Energy levels (E_C-E_I), capture cross sections (\sigma_n), and production rates of the deep levels determined using the DLTS data of the neutron irradiated n-type 6H–SiC samples.

<table>
<thead>
<tr>
<th>( E_C-E_I ) (eV)</th>
<th>( \sigma_n ) (cm²)</th>
<th>Production rate (cm⁻¹)</th>
<th>Electron irradiated</th>
<th>Proton and deuterium implanted</th>
<th>He implanted</th>
</tr>
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<tbody>
<tr>
<td>0.23</td>
<td>(-10^{-15})</td>
<td>-0.02</td>
<td>ED1 (0.27 eV) [Ref. 6]</td>
<td>( E_I/E_2 ) (0.38/0.44 eV), ( \sigma=10^{-14} \text{ cm}^{-2} ) [Ref. 5]</td>
<td>( E_I/E_2 ) (0.39–0.43 eV), ( \sigma=10^{-14} \text{ cm}^{-2} ) [Ref. 4]</td>
</tr>
<tr>
<td>0.36/0.44</td>
<td>(-10^{-14})</td>
<td>-0.4/0.5</td>
<td>( E_I/E_2 ) (0.38/0.44 eV), ( \sigma=10^{-14} \text{ cm}^{-2} ) [Ref. 5]</td>
<td>( E_I/E_2 ) (0.36/0.40 eV), ( \sigma=10^{-15} \text{ cm}^{-2} ) [Ref. 8]</td>
<td>( E_5 (0.43–0.47 eV), \sigma=10^{-15} \text{ cm}^{-2} ) [Ref. 4]</td>
</tr>
<tr>
<td>0.50</td>
<td>(-10^{-15})</td>
<td>-0.7</td>
<td>( E_5 (0.51 \text{ eV}), \sigma=10^{-15} \text{ cm}^{-2} ) [Ref. 5]</td>
<td>( 0.51 \text{ eV} )</td>
<td>( 0.51 \text{ eV} )</td>
</tr>
<tr>
<td>0.62/0.68</td>
<td>(-10^{-16})</td>
<td>-0.6/0.7</td>
<td>( Z_1/Z_2, \sigma=10^{-16}–10^{-17} \text{ cm}^{-2} ) [Ref. 5]</td>
<td>( 0.62/0.64 \text{ eV}, [Ref. 7] )</td>
<td>( Z_1/Z_2 (0.65–0.72/0.58–0.63 \text{ eV}), \sigma=10^{-15}–10^{-14} \text{ cm}^{-2} ) [Ref. 4]</td>
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III. RESULTS

Figure 1 shows the DLTS spectra of the as-irradiated n-type 6H–SiC samples with neutron doses of 5.1×10^{13}, 2.5×10^{14}, and 1.0×10^{15} n/cm², respectively. Six major peaks are observed in these spectra having activation energies of E_{C} = 0.23, E_{C} = 0.36, E_{C} = 0.44, E_{C} = 0.50, E_{C} = 0.62, and E_{C} = 0.68 eV, the closely spaced 0.36/0.44 eV levels, and 0.62/0.68 eV levels overlapping with each other to give broad peaks that can only be decomposed. DLTS measurements performed on un-irradiated Schottky contacted epitaxial layer control samples did not reveal any deep levels with concentration above ~10^{13} cm⁻³, indicating that all the observed defect levels are neutron induced.

The fluence dependence of the defect concentrations evaluated using the present DLTS data is shown in Fig. 2. As can be seen, the observed deep levels depend proportionally on neutron dose, again indicating that they are neutron irradiation introduced. The energy levels, capture cross sections and introduction rates of the deep levels are summarized in Table I. It was reported by individual groups that in n-type 6H–SiC, deep level defects labeled ED1, E₁/E₂, E₁ (or RD5) and Z₁/Z₂ are induced by electron irradiation,⁸ deuterium,⁷ or He implantation.⁶¹⁰ The activation energies and capture cross sections of these deep level defects as reported by these other workers are also listed in Table I for reference. Good agreement is seen between the parameters of the present neutron irradiation induced defects and those reported from the previous studies. Thus, the present observed deep levels E_{C} = 0.23, E_{C} = 0.36/0.44, E_{C} = 0.50, and E_{C} = 0.62/0.68 eV are believed to be the levels ED1, E₁/E₂, E₁ (or RD5), and Z₁/Z₂, respectively, and the same nomenclature is retained in this study.

As shown in the DLTS spectrum of the 2.5 ×10^{14} n/cm² dose as-irradiated sample in Fig. 1, it can be seen that the amplitude ratio of the E₁/E₂ peak to the E₁ peak is roughly 0.4/1 and referencing the peak height of E₁/E₂ to Z₁/Z₂ gives a similar ratio. These relative intensities are quite different from those reported in the electron-irradiated 6H–SiC material where one typically finds the E₁ and Z₁/Z₂ peaks an order of magnitude less in intensity than E₁/E₂.⁵⁻⁷ The increased importance E₁ and of Z₁/Z₂ peaks in the neutron-irradiated material is consistent with the as-irradiated samples being implanted by heavy particles (like deuterium⁷ and He⁶¹⁰).

To investigate the thermal annealing behavior of the observed deep level defects, 100–1600 °C isochronal annealing was performed on the as-irradiated samples with each of the annealing steps lasting for 30 min. Figure 3 shows some of the typical DLTS spectra of the neutron-irradiated samples annealed at temperatures between 200 and 1400 °C, from which the extinction of the deep levels ED1, E₁/E₂, E₁, and Z₁/Z₂ during the annealing process are clearly seen. Isochronal annealing curves for the normalized DLTS signal intensities of ED1, E₁/E₂, E₁, and Z₁/Z₂ are shown in Fig. 4 from which it may be seen that ED1 and E₁ both anneal out below 350 °C. On the other hand, the level E₁/E₂ increases with annealing temperature, reaching a maximum at temperature of ~500 °C, thereafter dropping and reaching the DLTS signal limit (~10^{12} cm⁻³) above 1400 °C. For the case of Z₁/Z₂, the intensity decreases slightly with sample annealed up to 500 °C and then undergoes a drastic decrease at ~750 °C, finally falling below the DLTS signal limit at 900 °C.

Annealing at temperatures beyond 1400 °C produces some interesting results. Figure 5 shows the DLTS spectra of the 500 and the 1600 °C annealed neutron-irradiated n-type 6H–SiC samples. A 1600 °C annealing of un-irradiated control sample was also performed with the corresponding DLTS spectrum also included in Fig. 5. For the neutron irradiated sample, although all the deep levels ED1, E₁/E₂, E₁, and Z₁/Z₂ have already annealed out at the annealing temperature of 1400 °C, four additional DLTS peaks (denoted by NE1–NE4) are observed after the 1600 °C annealing. Arrhenius plots for the NE1–NE4 deep levels are shown in Fig. 6. The activation energies and capture cross sections of the NE1–NE4 levels are summarized in Table II. Moreover,
these four peaks can also be seen in the DLTS spectrum of the 1600 °C annealed nonirradiated sample, although the peak intensities are much lower than those of the 1600 °C annealed neutron-irradiated sample.

IV. DISCUSSION

A. **ED1 level**

It can be seen in Fig. 1 that the neutron induced level ($E_C - 0.23$ eV) level is a relatively weak DLTS peak. Its activation energy is close to that of $ED1 (E_C - 0.27$ eV), which was previously found in electron-irradiated 6H–SiC samples.\(^6\) Similar to the annealing temperature of $ED1 (~300 °C)$, the deep level $E_C - 0.23$ eV also anneals out at a relatively low temperature (~350 °C). Because of its low annealing temperature, Gong et al.\(^6\) suggested that $ED1$ was possibly related to an interstitial defect as such sites have a relatively low migration energy.

B. **$E_i$ level**

The $E_C - 0.50$ eV level in the present neutron-irradiated experiment is very close to the $E_i$ deep level found in the electron-irradiated at $E_C - 0.51$ eV\(^5,7\) and the level $RD5$ (at $E_C - 0.5$ eV) found in He implanted 6H–SiC materials.\(^4\) Aboelfotoh and Doyle\(^7\) have reported the electron-irradiation-induced $E_C - 0.51$ eV level to anneal out below 300 °C while Dalibor et al. have shown the He implantation induced $RD5$ to be significantly reduced after a 430 °C annealing.\(^4\) In the present neutron irradiated sample, this deep level anneals at about 350 °C. The annealing behavior of the $E_C - 0.51$ eV observed in Aboelfotoh and Doyle’s study (and also the $E_C - 0.50$ eV level in the present study) is very similar to that of the $T5$ center found in Itoh et al.’s EPR study of electron and proton irradiated $p$-type 3C–SiC, which was attributed to a positively charged carbon vacancy $V_C^+$.\(^21\) The $T5$ center was found to anneal out ~300 °C. This led that the $E_i$ level is suggested to be related to a carbon vacancy. However, in a more recent EPR study, Son, Hai, and Janzén\(^22\) have identified the $EI5$ center, which anneals at 500 °C, as a positively charged carbon vacancy $V_C^+$, an annealing temperature that coincides with the carbon vacancy as seen from positron lifetime measurements.\(^23,24\) Son and co-workers further argued the $T5$ is not a $V_C^+$ defect but possibly a $V_C^++nH(n=1,2)$ complex.\(^22\) In summary, the evi-
vidence strongly points towards \( E_i \) being a \( V_C \) or a \( V_C \) related complex with the possibility of hydrogen association requiring further investigation.

C. \( E_1/E_2 \) levels

For the case of the \( E_1/E_2 (E_C-0.36/0.44 \text{ eV}) \) level, the introduction rate and thermal annealing behavior observed on the present neutron irradiated \( n \)-type 6\( H \)–\( SiC \) is markedly different from those observed for electron irradiated samples.\(^5\)–\(^7\) As noted while \( E_1/E_2 \) are usually the dominant peaks in the DLTS spectra of electron-irradiated \( n \)-type 6\( H \)–\( SiC \) materials, the relative intensity of \( E_1/E_2 \) in the neutron-irradiated material is low (see Fig. 1). Speculation that the relative lower intensity of \( E_1/E_2 \) in the neutron-irradiated spectrum is due to the effect of the deep level occupancy, which is determined by the Fermi level position, can be ruled out. First, in the present study, the total concentration of observed deep levels which could act as potential compensating centers was at least one order of magnitude smaller than the dopant concentration. Second, the observation of the \( ED1 \) level indicates that the Fermi level is at least high enough to populate the level at \( E_C-0.23 \text{ eV} \). Third, the low relative intensity is a general consistency with DLTS spectra seen under heavy particle irradiation. More specifically, the observed \( E_1/E_2 \) intensity increases with annealing temperature in the present neutron-irradiated samples becoming dominant at 500 °C and persisting until annealing temperatures of 1200 °C. The observation of similar increasing and subsequent decreasing behavior, together with a similarly relatively low \( E_1/E_2 \) intensity, is also seen in other \( n \)-type 6\( H \)–\( SiC \) samples irradiated with heavy particles, like He (Ref. 4) or deuterium.\(^7\) For He and deuterium irradiated samples, the \( E_1/E_2 \) peak is found to be dominant at the annealing temperatures of 430 and 800 °C, respectively.\(^4\)\(^,\)\(^7\)

The microstructure of \( E_1/E_2 \) is still not yet confirmed with possible suggestions being the negatively charged carbon vacancy \( V_C \),\(^7\) a divacancy \( V_C V_Si \),\(^6\) or a complex consisting of a \( V_Si \).\(^25\)\(^,\)\(^26\) Other than these suggestions, one clue to the possible identity of the \( E_1/E_2 \) defect comes from the work of Lingner, Greulich-Weber, and Spieß\(^1\) who have studied neutron irradiated \( n \)-type 6\( H \)–\( SiC \) sample with electron paramagnetic resonance (EPR), magnetic circular dichroism of the absorption (MCDA) and MCDA detected EPR (MCDA-EPR). \( P6/P7 \) centers were detected only in neutron irradiated samples after a 600 °C annealing, but not in the un-irradiated or the as-irradiated samples. The \( P6/P7 \) signal was found to persist at 1200 °C annealing. Theoretical modeling performed by these authors showed the carbon antisite carbon vacancy \( C_S V_C \) center to be the only simple structure capable of producing the observed optical transitions and it was proposed that \( C_S V_C \) forms through the reaction \( V_Si+C_C\rightarrow C_S V_C \) during the annealing process. The observation made in the neutron irradiated \( n \)-type 6\( H \)–\( SiC \) materials that, the intensities of the deep levels \( E_1/E_2 \) and the \( P6/P7 \) centers were small in the un-irradiated or the as-irradiated samples but increased after the 600 °C annealing could thus be possibly explained if \( E_1/E_2 \) and \( P6/P7 \) originated from the same defect \( C_S V_C \).

As the \( E_1/E_2 \) intensities keep on increasing in the range of annealing temperatures up to 500 °C and reach the maximum at this temperature, we would point out that if \( C_S V_C \) is responsible for \( E_1/E_2 \) it is unlikely that these sites are all created from the mobility and annihilation of a \( V_Si \) since the silicon vacancy is known to be stable in the temperature range up to \( \sim 700 \text{ °C} \). For example, using the positron lifetime technique, Ling, Beling, and Fung\(^23\) have observed that \( V_Si \) related defect in \( n \)-type 6\( H \)–\( SiC \) anneals only after 650 °C annealing. Moreover, Sörman et al.\(^27\) have noted the stability of photoluminescence (PL) lines associated with the isolated silicon vacancy, up to 750 °C. It is more likely that there exists another channel that the \( C_S V_C \) defect could form through. Since the \( V_C \) related defect is mobile in the temperature below 500 °C (see discussed on \( E_i \) level above), one of the possible formation reactions is through the process \( V_C+C_S\rightarrow C_S V_C \), since it is known that the carbon antisite has low formation energy, which is likely to be the most common native defect in as-grown \( SiC \).\(^28\) Such a formation is consistent with the observation that the decrease of the \( E_i \) annealing curve coincides well with the increase of the \( E_1/E_2 \) intensities [Figs. 3 and 4(a)]. While looking promising, the identification of \( E_1/E_2 \) with \( C_S V_C \) is not unambiguously proved and further investigations are certainly needed for further clarification.

D. \( Z_1/Z_2 \) and \( NE3/NE4 \) levels

Earlier thermal annealing studies indicated that the \( Z_1/Z_2 \) centers persisted at annealing temperatures up to 1700 °C,\(^2\)\(^,\)\(^3\) in contradiction with the present study which shows the levels to have completely annealed out by 900 °C and other recent results showing that the \( Z_1/Z_2 \) deep levels disappear at temperatures below 1000 °C.\(^6\)\(^,\)\(^7\) The early study can be explained from the observation in the present study,
that as the \( Z_1/Z_2 \) levels anneal so two new deep level centers (\( NE3 \) and \( NE4 \)) having very close ionization energies to those of \( Z_1/Z_2 \) are generated upon the 1600 °C annealing. It is thus possible that the deep levels termed \( Z_1/Z_2 \) reported stable up to 1700 °C in the earlier study are indeed the \( NE3/NE4 \) annealing induced deep levels defects. To support this view we point out that under the same rate window settings the peak position temperatures of the \( NE3 \) and \( NE4 \) deep levels are about 40 K higher than those of the \( Z_1/Z_2 \) levels (Fig. 5), indicating that the capture cross sections for \( NE3/NE4 \) defects are lower than those of the \( Z_1/Z_2 \) centers (as can also be seen from the Arrhenius plots of Fig. 6). Although cross sections can vary greatly for samples with different strain and with different modes of carrier scattering, the different cross sections indicate that the \( NE3/NE4 \) centers are either a modified form of the \( Z_1/Z_2 \) centers or are of a completely different structure. The fact that the 900 °C anneal completely removes \( Z_1/Z_2 \) [Fig. 3(c)] also supports the view that the structures responsible for these levels have been removed by annealing and thus that the \( NE3/NE4 \) levels are of a new origin.

The earlier study that suggested that \( Z_1/Z_2 \) was stable up to 1700 °C gave rise to the idea that the defect center could be \( V_{Si}V_C \). In view of the above observations that \( Z_1/Z_2 \) anneals at the much lower temperature range of 500–900 °C and the fact that this annealing behavior parallels that of the isolated silicon vacancy \( V_{Si} \) as seen by postion lifetime spectroscopy,\(^{23,24} \) and PL\(^{27} \) has led a number of workers to suggest that \( Z_1/Z_2 \) is produced by \( V_{Si} \).\(^{25,26} \) Moreover, measuring the positon lifetime spectra of irradiated 6H–SiC materials with monochromatic illumination, \( V_{Si} \) has been recently shown to have an ionization level at 0.6±0.1 eV below the conduction band, which indeed coincides with that of \( Z_1/Z_2 \).\(^{26} \) This identification can also explain the double peak nature of this level, with one peak coming from the hexagonal-site \( h \) and the other from the quasicubic-sites \( k_1, k_2 \).

E. \( NE1 \) and \( NE2 \)

The activation energies of the \( NE1 \) and \( NE2 \) levels found in the 1600 °C annealed samples are determined at \( E_C−0.23 \) eV (\( ED1 \)), \( E_C−0.36/0.44 \) eV (\( E_1/E_2 \)), \( E_C−0.50 \) eV (\( E_I \) or \( RD5 \)), and \( E_C−0.62/0.68 \) eV (\( Z_1/Z_2 \)) have been identified and studied. \( ED1 \) and \( E_I \) were observed to anneal out at relatively low temperatures (below 350 °C). It has been suggested that the structure of \( E_i \) is likely to be \( V_C \) related. Unlike the electron irradiated material, but similar to He and deuterium implanted, the \( E_1/E_2 \) are found not to be the dominant peaks in as-neutron-irradiated DLTS spectra. The fact that the intensity of increased \( E_1/E_2 \) first increases with annealing temperature, reaching a maximum at 500–750 °C and then annealing out at 1400 °C, has been tentatively interpreted, together with other evidence, in terms of the \( C_{Si}V_C \) center. The \( Z_1/Z_2 \) levels were found to anneal out at temperatures below 900 °C, while strongly suggesting that the \( V_{Si} \) defect for the responsible microstructure does not rule out other defect centers.

An important observation made in the present work has been that of the thermal generation of deep levels \( NE1–NE4 \) at annealing temperatures above 1400 °C. The evidence that we have given strongly suggests that these levels are not to be associated with either \( E_1/E_2 \) or \( Z_1/Z_2 \) but are indeed new defect levels happening to have very similar energy levels. While these new levels may be associated with microstructures very similar in some way to those responsible for \( E_1/E_2 \) or \( Z_1/Z_2 \), it is also possible that their origin could have no association with the origin of the \( E_1/E_2 \) or \( Z_1/Z_2 \) levels. It is too early to speculate on the origin of

V. SUMMARY

In summary, DLTS has been used to study deep level defects in n-type 6H–SiC materials induced by neutron irradiation. Additional isochronal annealing has also been performed in order to characterize the induced defects. Deep levels at \( E_C−0.23 \) eV (\( ED1 \)), \( E_C−0.36/0.44 \) eV (\( E_1/E_2 \)), \( E_C−0.50 \) eV (\( E_I \) or \( RD5 \)), and \( E_C−0.62/0.68 \) eV (\( Z_1/Z_2 \)) have been observed the electron traps labeled \( ID6 \) and \( ID7 \) having activation energies of 0.40–0.43 and 0.50–0.54 eV, respectively in n-type 6H–SiC samples implanted by vanadium and titanium followed by 30 min 1700 °C annealing. Second, electron traps \( BE2 \) and \( BE3 \) with identical activation energies to those of \( NE1 \) and \( NE2 \) have also been observed in Be implanted n-type 6H–SiC after annealing at 1600 °C.\(^{29} \) Thus in summary, the close similarity of the activation energies of the \( NE1 \) (and \( NE2 \)) deep levels observed in the present study with those of \( ID6/BE2 \) (and \( ID7/BE3 \)) found in high temperature annealed ion implanted n-type 6H–SiC materials (refer to Table II), made it reasonable to suggest that \( NE1 \) is probably the same level as \( ID6/BE2 \) and \( NE2 \) the same level as \( ID7/BE3 \).

It is also worth pointing out that \( NE1–NE4 \) can also be observed in the 1600 °C annealed un-irradiated sample, despite the fact that their intensities are much lower than those in the neutron-irradiated sample. As these four peaks are not found in the as-grown sample (DLTS measurement performed but not shown), this implies the observed \( NE1–NE4 \) defects are the products of the thermal annealing. As the neutron irradiation enhances the formation of these defects, it implies some of the neutron-irradiation induced defects are possibly involved in the reaction that leads to the formation of \( NE1–NE4 \).

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NE1–NE4, but it is hoped that the evidence given that these defects are indeed different than $E_1/E_2$ or $Z_1/Z_2$ will stimulate further research into their microscopic origin.

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